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CONFIRMATION NO. 8169

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/685,515	10/16/2003 RULE	134	1746	249 / 255 DIV

APPLICANTS

Im-soo Park, Seoul, KOREA, REPUBLIC OF;

Kun-tack Lee, Suwon-city, KOREA, REPUBLIC OF;
Yong-pil Han, Seoul, KOREA, REPUBLIC OF;Sang-rok Hah, Seoul, KOREA, REPUBLIC OF;

** CONTINUING DATA **********
This application is a DIV of 09/899,226 07/06/2001 PAT 6,712,078

** FOREIGN APPLICATIONS **********
REPUBLIC OF KOREA 01-2065 01/13/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 06/02/2004

Foreign Priority claimed ☑ yes ☐ no 35 USC 119 (a-d) conditions met ☑ yes ☐ no ☐ Met after Allowance Verified and Acknowledged Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1

ADDRESS
LEE & STERBA, P.C.
SUITE 2000
1101 WILSON BOULEVARD
ARLINGTON , VA
22209

TITLE
Apparatus for cleaning semiconductor wafer and method for cleaning wafer using the same

☐ All Fees
☐ 1.16 Fees (Filing)